



Docket No.: 1572.1117

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Kwang-il KIM et al.

Serial No. 10/628,244

Group Art Unit: 3652

Confirmation No. 5449

Filed: July 29, 2003

Examiner: Donald W. Underwood

For: SEMICONDUCTOR WAFER TRANSFER APPARATUS

AMENDMENT

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

This is in response to the Office Action mailed March 7, 2005, and having a period for response set to expire on June 7, 2005.

A petition for a one-month extension of time is concurrently filed herewith, thereby extending the response due date to July 7, 2005.

The following amendments and remarks are respectfully submitted. Reconsideration of the claims is respectfully requested.

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